

CLEAN ROOM CONTACT NUMBERS

Name	Phone	Expertise
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Russ Hajdaj <i>russ.hajdaj@nist.gov</i>	301-975-2699	➤ Facility infrastructure, safety ➤ Furnaces, wet decks, dicing saw
Gerard Henein <i>gerard.henein@nist.gov</i>	301-975-5645	➤ Metallization, wire bonding
Rich Kasica <i>richard.kasica@nist.gov</i>	301-975-2693	➤ E-beam lithography, SEM, FIB
Bill Young <i>bill.young@nist.gov</i>	301-975-4467	➤ Equipment maintenance, modification and installation. ➤ Basic process support
Anthony Novembre <i>Anthony.novembre@nist.gov</i>	301-975-2886	➤ Facility Operations ➤ E-beam lithography
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